



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yasunori, et al.

Attorney Docket No.: MURTP083D1

Application No.: 10/640,850

Examiner: H.D. Wilkins III

Filed: August 13, 2003

Group: 1742

Title: METHOD OF PRODUCING CERAMIC  
THERMISTOR CHIPS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 28, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Deborah Neill

REQUEST FOR STATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on August 13, 2003 and no response has been received as of this date.

Respectfully submitted,

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